

35.C15518



PATENT APPLICATION

14201

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TOHRU DEN ET AL.) Examiner: Not Yet Assigned
Application No.: 09/895,464) Group Art Unit: Not Yet Assigned
Filed: July 2, 2001)
For: METHOD OF MANUFACTURING)
STRUCTURE WITH PORES AND :
STRUCTURE WITH PORES) August 15, 2001

Commissioner for Patents
Washington, D.C. 20231

SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The concise explanation of relevance for the non-English documents may be found, inter alia, in the specification where they are cited. Also, the concise explanation of relevance for the Japanese patent publications may be found in the English abstracts attached thereto. In addition, a concise explanation of relevance for JP 10-121292 may be found in the corresponding U.S. Patent No. 6,139,713, a copy of which is enclosed.

The Examiner's attention is also directed to the following U.S. Application:

APPLICATION NO.

FILING DATE

GROUP ART UNIT

09/767,851

01/24/01

2825

A copy of this Application is enclosed.




CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

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FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

ATTY DOCKET NO. **35.C15518**

APPLICATION NO. **09/895,464**

APPLICANT **Tohru Den et al.**

FILING DATE **July 2, 2001**

GROUP **N.Y.A.**

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,214,738B1	04/10/01	Aiba et al.	438	707	
	6,139,713	10/31/00	Masuda et al.	205	206	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP 11-224422	08/17/99	Japan			Abstract
	JP 10-121292	05/12/98	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

	Hideki Masuda et al., "Fabrication of a One-Dimensional Microhole Array by Anodic Oxidation of Aluminum," 63(23) Appl. Phys. Lett. 3155-3157 (1993).
	H. Masuda, 31(5) Solid State Physics 493-499 (1996).
	R.C. Furneaux et al., "The Formation of Controlled-Porosity Membranes From Anodically Oxidized Aluminum," 337 Nature 147-149 (1989).
	Hideki Masuda et al., "Fabrication of Gold Nanodot Array Using Anodic Porous Alumina as an Evaporation Mask," 35(2) Jpn. J. Appl. Phys. 35(2) L126-L129 (1996).

EXAMINER _____ DATE CONSIDERED _____

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1